

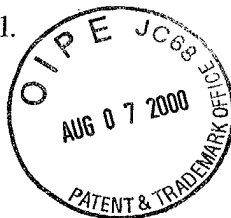
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: N. FUKASAWA et al.

Serial Number: 09/029,608

Filed: May 15, 1998

For: **METHOD AND MOLD FOR MANUFACTURING SEMICONDUCTOR DEVICE, SEMICONDUCTOR DEVICE, AND METHOD FOR MOUNTING THE DEVICE**



Group Art Unit: 2814

Examiner: D. Graybill

GP 2814\$  
#20  
8-15-00  
Payton

**INFORMATION DISCLOSURE STATEMENT AND  
CERTIFICATION PURSUANT TO 37 CFR 1.97(c)**

Director of Patents and Trademarks  
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

August 7, 2000

Sir:

The attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. One copy of each of these references is attached along with a Korean Office Action.

This Information Disclosure Statement is being submitted after issuance of a first official action on the merits and expiration of the three month period following filing of the above-captioned application, but prior to issuance of either a final official action or a Notice of Allowance. A check is attached hereto which covers the \$240.00 fee set forth in 37 CFR § 1.17(p).

The undersigned hereby certifies that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

The above information is presented so that the Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that

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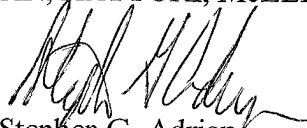
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the information be expressly considered during the prosecution of this application, and that the references cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement. Two copies of this authorization are attached.

Respectfully submitted,

ARMSTRONG, WESTERMAN, HATTORI, McLELAND & NAUGHTON



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Enclosures: PTO-1449, 5 References and Korean Office Action